

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Masahiro Ishida et al.

Application No.: 10/779,904

Confirmation No.: 9608

Filed: February 17, 2004

Art Unit: 2436

For: METHOD AND APPARATUS FOR DEFECT  
ANALYSIS OF SEMICONDUCTOR  
INTEGRATED CIRCUIT

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Examiner: O. A. Louie

**REPLY UNDER 37 CFR § 1.111**

MS: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated January 14, 2010, please reconsider this application in view of the following.